

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Serial No.: 10/808,691
Applicant: Kostenko et al.
Title: **METHOD AND PROCESSING SYSTEM FOR PLASMA-
ENHANCED CLEANING OF SYSTEM COMPONENTS**
Attorney Docket: FKL-017
Confirmation No.: 6065

Cincinnati, Ohio 45202

June 7, 2006

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT
STATEMENT OF CERTIFICATION UNDER § 1.704(d)

Each item of information contained in this Information Disclosure Statement was first cited in a communication from a foreign patent office in a counterpart application and, to the knowledge of the person signing the certification after making reasonable inquiry, this communication was not received by any individual designated in 37 C.F.R. § 1.56(c) more than thirty days prior to the filing of this Information Disclosure Statement.

Applicants do not believe that any fees are due in connection with this submission. If any additional charges or credits are necessary to complete this communication, please apply them to Deposit Account No. 23-3000.

Respectfully submitted,

WOOD, HERRON & EVANS, L.L.P.

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